

EL979949448

Inventor: Cem Basc ri



Title: Capacitor Constructions Comprising P rovskit -Typ Dielectric Materials

Assignee: Micron Technology, Inc.

Serial No.: 10/086,942

Filed: March 1, 2002 [RCE Filed Herewith]

**INFORMATION DISCLOSURE STATEMENT**

**PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98**

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, the Examiner's attention is directed to the references listed on the attached Form PTO-1449 and copies of which are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

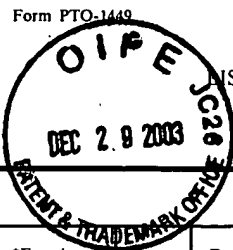
Date: 12/29/03

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Form PTO-1449

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.  
MI22-1951SERIAL NO.  
10/086,942LIST OF ART CITED BY APPLICANT  
(Use several sheets if necessary)APPLICANT  
Cem BasceriFILING DATE  
3/1/02 [RCE Filed Herewith]GROUP  
2813

## U.S. PATENT DOCUMENTS

*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
AA	6,236,076 B1	05/01	Arita et al.			
AB	6,285,051 B1	09/01	Ueda et al.			
AC	5,635,741	06/97	Tsu et al.			
AD	6,422,281 B1	07/02	Ensign Jr. et al.			
AE	6,527,028 B2	03/03	Miller			
AF	6,602,376 B1	08/03	Bradshaw			
AG						
AH						
AI						
AJ						
AK						
AL						

## FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
AM							
AN							
AO							
AP							
AQ							

## OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

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AS		
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.